

Form PTO-1449 <b>INFORMATION DISCLOSURE CITATION IN AN APPLICATION</b> (Use several sheets if necessary)			Docket Number (Optional) <b>3439.4US (97-936.3)</b>	Application Number <b>Not Yet Assigned</b>
			Applicant <b>Jigish D. Trivedi et al.</b>	10/600,497
			Filing Date <b>October 24, 2001</b>	Group Art Unit <b>Unknown</b>

JC871004  
 10/24/01

**U.S. PATENT DOCUMENTS**

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
✓	4,975,756	12/1990	Haken et al.	257	371	-
✓	5,124,280	06/1992	Wei et al.	438	618	-
✓	5,173,450	12/1992	Wei	438	620	-
✓	5,341,016	08/1994	Prall et al.	257	412	-
✓	5,391,520	02/1995	Chen et al.	438	620	-
✓	5,451,545	09/1995	Ramaswami et al.	438	649	-
✓	5,597,744	01/1997	Kamiyama et al.	438	285	-
✓	5,654,575	08/1997	Jeng	257	384	-
✓	5,766,997	06/1998	Takeuchi	438	257	-
✓	5,981,380	11/1999	Trivedi et al.	438	639	-

**FOREIGN PATENT DOCUMENTS**

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO

**OTHER DOCUMENTS**

(Including Author, Title, Date, Pertinent Pages, Etc.)

✓	T. Tang, et al., <i>Titanium Nitride Local Interconnect Technology for VLSI</i> , IEEE Trans. Electron Devices, Vol. ED-34, 3 (1987) p. 682.

EXAMINER	DATE CONSIDERED
HUNG K. JU	10/29/02

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.